

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF: Jaehwan EUN, et al
SERIAL NO: 10/539,886
FILED: June 17, 2005 CONFIRMATION NO: 1951
TITLE: METHOD FOR PREPARING FILM STRUCTURE
COMPRISING FERROELECTRIC SINGLE
CRYSTAL LAYER
GROUP: 1791 EXAMINER: Sonya MAZUMDAR

PRELIMINARY AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

SIR:

This Amendment is being filed concurrently with the filing of an RCE for the above-identified application. The Commissioner is hereby authorized to deduct any required fees in the prosecution of this application to Applicant's Deposit Account No. 504581.

Please amend the present application as follows: